PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

pplication of

Masatake NAKANO et al.

Group Art Unit: 1763

Application No.: 09/857,569

Examiner:

G. Goudreau

Filed:

June 7, 2001

Docket No.:

109716

For:

METHOD FOR PRODUCING BONDING WAFER AND BONDING WAFER

CONFIRMATION OF TELEPHONE ELECTION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

A telephone requirement for restriction was made in connection with the above-identified patent application on August 6, 2003.

The undersigned confirms that in response to that telephone requirement, a provisional election was made to prosecute Group I, claims 10-22.

Said provisional election was specifically made with traverse since no basis therefor has been set forth in the written record.

Further, it is respectfully submitted that the Requirement is improper as this is a PCT-US National Stage Application, U.S. domestic law cannot be applied to the application (PCT Art. 27(1)) and the judgment must be made on PCT Rule 13. The International Bureau searched all claims 1-9 of the originally filed application and identified art applicable to all claims 1-9 indicating a belief there is unity of invention.

Therefore, the withdrawal of the Requirement is respectfully requested and the examination of the entire application is respectfully requested.

Respectfully submitted,

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WPB:SSK/tbh

Date: August 7, 2003

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